

Alkali antimonide photocathode performance in ultrafast electron microdiffraction

Cameron Duncan and William Li Cornell University



MEDUSA

- Ultrafast Electron Diffraction (UED) is a time-resolved technique for studying materials out of equilibrium
- Conservation of six-dimensional brightness imposes a trade-off between spatial and temporal resolution in UED
- Machines that deliver 100 fs or shorter electron pulses typically produce rms transverse beamsizes 25 um or greater
- With a low MTE electron source, we form single micron size probes while maintaining 100s of femtosecond temporal resolution





Microdiffraction

 Small probes make possible the study of small samples, e.g., flakes of materials that are challenging to prepare as large single crystals



Diffraction sample, Nb₃Br₈



Beamline overview





Beamline overview





Beamline overview





Beamline overview





Beamline overview





Beamline overview





Beamline overview





Cathode

Na-K-Sb cathode grown at Cornell



- These cathodes have previously been measured to have high (percent-level) QE in the green and low (~35 meV) MTE at threshold
 - In simulation, decreasing MTE has a noticeable effect on emittance at the sample, around a factor of 2 at sub-picosecond bunches





Cathode transfer

- The vacuum in all components of the cathode transfer process is kept under 10⁻¹⁰ Torr
- Compact suitcase fits inside the beamline's lead shielding
- Our Na-K-Sb photocathodes retain QEs in the 10⁻⁴ level at 650 nm after transfer to the gun

Cathodes grown on INFN/DESY/LBNL style miniplug









Suitcase attachment

Growth chamber

Vacuum suitcase



Vacuum

- Baking out sample chamber is impractical
- Conductance aperture and NEG can between sample chamber and beamline
- Gun remains below 10⁻¹¹ Torr even with the sample chamber at 10⁻⁸ Torr.
- We've been able to use same photocathode for >800 hours of runtime





Laser setup

- We split a 1030 nm seed, generating 515 nm light for the pump and 650 nm light for the cathode
- 650 nm is chosen as it is near threshold but remains in the linear photoemission regime





Emittance

- We can measure the emittance at the sample plane with a knife edge
- <15 nm normalized emittance in x
- 9 nm normalized emittance in y
- Right in the blue rectangle









Spatial resolution

- 10 µm aperture placed just before sample (~500 electrons through)
- We characterize the size of the electron beam in two different ways
 - 1. TEM grid scan (a)-(c)
 - a. Also gives us spatial overlap with pump beam
 - 2. Direct knife edge scan (d)





Spatial resolution







Single TEM grid square



Transmission scan of TEM grid



Emittance (apertured)

- At waist, $\varepsilon = \sigma_x \sigma_{x'}$
- For the ~500 electrons passing through aperture:
 0.7 nm normalized emittance!





Bunch length

• The bunch length can be obtained by measuring the beam size along an rf deflection axis.





Gold UED



Signal S is the *relative* change in intensity *I*:

$$S = \frac{I_{hot} - I_{cold}}{I_{cold}}$$

In our experiment, $|S| \sim 1\%$

-4.5 -3.2 -1.9 -0.6 0.7 2.0 3.3 4.6 ps

tors, SLAC, November 10th-12th, 2021



Gold UED





Gold UED





Gold UED





Acknowledgements

Maxson Group







Alice Galdi

Now at U. Salerno.

Bazarov Group





Jai Kwan Bae

Now at BNL



Cornell Electron Microscopy







U. Chicago Beam Dynamics





Conclusion

- MEDUSA is an operational UED beamline running low MTE Na-K-Sb photocathodes at threshold, in the linear photoemission regime
- Low MTE enables subpicosecond, micron scale bunches with hundreds of electrons per bunch and fine reciprocal space resolution



Diffraction sample, Nb₃Br₈